

RECEIVED
CENTRAL FAX CENTER

OCT 02 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: HIMI et al.

Serial No.: 10/716,606

Filed: 11/20/2003

Title: METHOD FOR MANUFACTURING
SEMICONDUCTOR SUBSTRATE

Atty. Dkt.: 01-100-DIV

Art Unit: 2813

Examiner: Thanhha S. PHAM

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: 2 October 2006

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the USPTO (Fax. No. 571-273-8300) on 2 October 2006
Typed Name: Kerry S. CulpepperSignature: Kerry S. Culpepper**REPLY UNDER 37 CFR 1.116**

Sir:

OK to
w/1/10/06
only
TSB

In response to the office action mailed 2 June 2006, please amend the application as follows:

Remarks begin on page 2 of this paper.